

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/805,620
Confirmation No. 3004
Filing Date March 13, 2001
Inventor Craig M. Carpenter
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Kelly M. Stouffer
Customer No. 021567
Attorney's Docket No. MI22-1563
Title: Chemical Vapor Deposition Methods (Amended)

INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO/SB/08a

In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO/SB/08a. No admission is made regarding whether all the submitted references are prior art.

This Information Disclosure Statement is being filed together with the filing of a Request for Continued Examination (RCE) Application. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Citation of these references is respectfully requested.

Respectfully submitted,

January 8, 2008
Dated: _____

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